

Atty. Docket No.042390.P4220

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

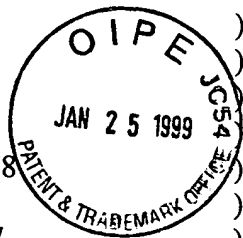
Mark T. Bohr

Application No. 09/002,178

Filed: December 31, 1997

For: WAFER PASSIVATION
STRUCTURE AND METHOD
OF FABRICATION

Asst. Commissioner for Patents
Washington, D.C. 20231



Examiner: Oh, E.

Art Unit: 2822

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231

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PRELIMINARY AMENDMENT

Sir:

Prior to examination of this application, Applicant respectfully requests that the Examiner enter the following amendment.

IN THE CLAIMS

Please cancel Group I claims, claims 21-30, drawn to a semiconductor device, before calculating the filing fee for the present application. Applicant request to prosecute Group II claims, claims 1-20, drawn to a process of making a semiconductor device apparatus.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

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FEB 01 1999

GROUP 2100

Date: 1/19, 1999

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